



MIT.9889

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Lee et al. GROUP: 2815
SERIAL NO: 10/603,712 EXAMINER: A.R. Wilson
FILED: June 25, 2003
FOR: A METHOD FOR IMPROVING HOLE MOBILITY
ENHANCEMENT IN STRAINED SILICON P-TYPE
MOSFET

Mail Stop Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE

In response to the Office Action mailed February 22, 2004, please amend the
above-identified application as follows:

*OKAY TO ENTER.
Q. W. 6/21/05*